



1110-3:MRS:as:289854

AF/1775  
LFW

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re patent application of: )  
 )  
Hiromichi Ohta, et al. ) Before the Examiner  
 )  
Serial No. 09/615,883 ) Jennifer C. McNeil  
 )  
Filed July 14, 2000 ) Group Art Unit 1775  
 )  
LOW-RESISTANCE ITO THIN ) June 29, 2004  
 )  
FILM AND METHOD FOR )  
MANUFACTURING SUCH )  
A FILM )

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to the Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313 on

June 29, 2004

Date of Deposit

Matthew R. Schantz

Name of Registered Representative

*Matthew R. Schantz*  
Signature

June 29, 2004

Date of Signature

AMENDMENT AFTER FINAL ACTION

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313

Sir:

In response to the Final Office Action entered in the above application and dated March 29, 2004 ("Office Action" herein), please consider the following. Applicants believe that this paper is fully responsive and being filed within the shortened statutory period, so that no extension of time is necessary. If such an extension is, or any additional fees are due, please charge them to Account No. 23-3030, but not to include any payment of issue fees.

An Amendment to the Claims is reflected in the listing of claims that begins on page two of this paper.